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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Toshihide TSUBATA et al. Serial No.: Currently unknown Filing or 371(c) Date: Concurrently herewith Title: TRANSISTOR AND CVD APPARATUS USED TO DEPOSIT GATE INSULATING FILM THEREOF	International Application No.: PCT/JP2004/018051  International Filing Date: December 3, 2004
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**PRELIMINARY AMENDMENT**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits of the above-identified patent application,  
Applicants respectfully request entry and consideration of the following Amendment:

- ☒ **Amendments to the Specification** begin on page 2 of this paper.
- ☒ **Amendments to the Drawings** begin on page 3 of this paper and include an attached replacement sheet.
- ☒ **Amendments to the Claims** are reflected in the listing of the claims which begins on page 3 of this paper.
- ☒ **Remarks/Arguments** begin on page 5 of this paper.

Please note, if a box is not checked, then no corresponding amendment is being made.